



Attorney Docket no: SEL 194

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Suzawa et al.)
)
Serial No.: 09/615,449)
)
Filed: July 13, 2000)
)
For: Wiring And Manufacturing Method Thereof,)
Semiconductor Device Comprising Said)
Wiring, And Dry Etching Method)
)
Examiner: H. Trinh)
)
Art Unit: 2814)

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Washington D.C. 20231

ELECTION AND AMENDMENT B.

In response to the Restriction Requirement of October 1, 2001, a one month extension of time being separately requested, Applicants elect to prosecute Group II: Claims 12-15 in the above-identified application. Applicants are making this election without prejudice to later filing a divisional application on the non-elected claims.

IN THE CLAIMS:

Please amend the claims as follows:

Cancel Claims 1-11.